**Claims**

1. Device for drying disc-shaped substrates comprising
an elongated body (1),
which tapers upwards to form a wedge (A) having an angle $\alpha$ between two surfaces and an upper edge
wherein the upper edge is suitable for holding the disc-shaped substrates,
characterized in that the two surfaces comprise more than one hole (2) each forming channels, which extend to a lower drainage part (B) of the elongated body.

2. Device according to claim 1, characterized in that
the angle $\alpha$ is larger than 30° and smaller than 90°, preferably larger than 50° and smaller than 70°.

3. Device according to claim 1 or claim 2, characterized in that
the material used for the device comprises ceramic filled polyetheretherketone (CFM PEEK).

4. Device according to claim 1 to claim 3, characterized in that
the upper edge has a curvature radius of more than 0.1 mm and less than 1 mm.

5. Device according to claim 1 to claim 4, characterized in that
the channels have a diameter more than 0.5mm and less than 3mm.

6. Device according to claim 1 to claim 5, characterized in that
the drainage part (B) comprises a channel having a diameter more than 3mm and less than 8mm.

7. Device according to claim 1 to claim 6, characterized in that
the drainage part (B) has a length (L2) of more than 20mm and less than 26mm.

8. Device according to claim 1 to claim 7, characterized in that
the wedge (A) has a height (L1) of more than 4mm and less than 10mm.